

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:

Li et al.

Serial No.: 10/759,448

Filed: 01/16/2004

SPIN-ON PROTECTIVE COATINGS FOR WET-
ETCH PROCESSING OF MICROELECTRONIC
SUBSTRATES

Docket No.: 34393

Conf. No. 7830

Group Art Unit No.: 1773

Examiner: Jackson, Monique R.

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In response to the office action dated February 27, 2006, amendment and reconsideration of the above application is requested.